

D. Pawel
#11B
8/103



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RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
ART UNIT 1753

PATENT APPLICATION

~~DO NOT ENTER~~ 5382

OK TO ENTER

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: B.L. Mutschler
TAKAHARU KONDO ET AL.)	
	:	Art Unit: 1753
Application No.: 09/866,665)	
	:	
Filed: May 30, 2001)	
	:	
For: SILICON-TYPE THIN FILM)	
FORMATION PROCESS, SILICON	:	
TYPE THIN FILM, AND)	
PHOTOVOLTAIC DEVICE	:	July 25, 2003

BK 8/7/03

Commissioner for Patents
Mail Stop: AF
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE AFTER FINAL ACTION
AND PETITION FOR EXTENSION OF TIME

Sir:

Applicants petition to extend the time for response to the Office Action dated
March 25, 2003, to and including July 25, 2003. A check in the amount of \$110.00 for payment

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to:
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

July 25, 2003
(Date of Deposit)

Lock See Yu-Jahnes (Reg. No. 38,667)
(Name of Attorney for Applicants)

July 25, 2003
(Date of Signature)

07/30/2003 HBERHE 00000018 09866665
01 FC:1251 110.00 OP

of the extension fee is enclosed. Please charge any additional fee required for the extension, or credit any overpayment, to Deposit Account 06-1205.

In response to the Office Action, the Examiner is respectfully requested to consider the following: